

Docket No. 245161US3CIP



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tsutomu OKABE, et al.

SERIAL NO: 10/706,914

GAU: 1763

RCE FILED: HEREWITH (Application filed: November 14, 2003) EXAMINER:MOORE, K.

FOR: WAFER PROCESSING APPARATUS HAVING DUST PROOF FUNCTION

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a one month extension of time be granted to December 22, 2005 for

- filing a response to the Official Action dated: August 22, 2005.
- responding to the requirements in the Notice of Allowability dated:
- filing the Formal Drawings. The Issue Fee due has been timely filed.
- responding to the Notice to File Missing Parts of Application dated:
- filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- filing a Request for Continued Examination (RCE).
- Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$120.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAN,
MAIER & NEUSTADT, P.C.

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(OSMMN 05/03)

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